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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>( Not for submission under 37 CFR 1.99)</i>	Application Number	10576159
	Filing Date	
	First Named Inventor	ALLON GUEZ
	Art Unit	2121
	Examiner Name	
	Attorney Docket Number	DREX-1007US

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	5	6164837		2000-12-26	HAAKE	
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	1	AULT, Stanley K. et al., "A Computer Vision Based Machine for Automated Packaging of Photonics Components," LEOS Annual Meeting, 1996, pgs. 238-239, Vol. 2.	<input type="checkbox"/>
	2	BANERJEE, S. Riki and DRAYTON, Rhonda Franklin, "Micromachined Low Dispersion Interconnects for Optoelectronic Array Packaging," IEEE MTT-S Digest, 2002, pgs. 1565-1568.	<input type="checkbox"/>

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	3	GUEZ, Allon et al., "Multiple Objective Optimization Approach to Adaptive and Learning Control," International Journal of Control, 1992, pgs. 469-482, Vol. 56, No. 2. Abstract Only	<input type="checkbox"/>
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	5	JANG, Soon, "Automation Manufacturing Systems Technology for Opto-electronic Device Packaging," 2000 Electronic Components and Technology Conference, 50th Proceedings, 2000, pgs. 10-14.	<input type="checkbox"/>
	6	KURZWEG, Timothy P., "Optical Propagation Methods for System-Level Modeling of Optical MEM Systems," Ph.D. Thesis, University of Pittsburgh, Department of Electrical Engineering, 2002.	<input type="checkbox"/>
	7	KURZWEG, Timothy P. et al., "A Fast Optical Propagation Technique for Modeling Micro-Optical Systems," Proceedings of the 2002 Design Automation Conference, New Orleans, LA, 2002.	<input type="checkbox"/>
	8	KURZWEG, Timothy P. et al., "Modeling Optical MEM Systems," Journal of Modeling and Simulation of Microsystems, 2001, pgs. 21-34, Vol. 2, No. 1.	<input type="checkbox"/>
	9	KURZWEG, Timothy P. and MORRIS III, Arthur S., "Macro-Modeling of Systems Including Free-Space Optical MEMS," Third International Conference on Modeling and Simulation of Microsystems, Semiconductors, Sensors and Actuators (MSM00), San Diego, CA, 2000.	<input type="checkbox"/>
	10	LEVITAN, Steven P. et al., "Chatoyant: A Computer-Aided-Design Tool for Free-Space Optoelectronic Systems," Applied Optics, 1998, pgs. 6078-6092, Vol. 37, No. 26.	<input type="checkbox"/>
	11	LEVITAN, Steven P. et al., "System Simulation of Mixed-Signal Multi-Domain Microsystems with Piecewise Linear Models," IEEE Transactions on Computer-Aided Design of Integrated Circuits and Systems, 2003, pgs. 139-154, Vol. 22, No. 2.	<input type="checkbox"/>
	12	MARTINEZ, Jose A. et al., "Mixed-Technology System-Level Simulation," Analog Integrated Circuits and Signal Processing, 2001, pgs. 127-149, Vol. 29.	<input type="checkbox"/>
	13	VELSHER, Ben, "Application-Specific Optoelectronic Packaging," 2002 Electronic Components and Technology Conference, 52nd Proceedings, 2002, pgs. 794-800.	<input type="checkbox"/>

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	14	WU, Ming C., "Micromachining for Optical and Optoelectronic Systems," Proceedings of the IEEE, 1997, pgs. 1833-1856, Vol. 85, No. 11.	<input type="checkbox"/>
	15	YAMAUCHI, Kenji et al., "Automated Mass Production Line for Optical Module Using Passive Alignment Technique," 2000 Electronic Components and Technology Conference, 50th Proceedings, 2000, pgs. 15-20.	<input type="checkbox"/>
	16	KURZWEG, Timothy P. et al., "Model Based Opto-Electronic Packaging Automation," IEEE Journal of Selected Topics in Quantum Electronics, 2004, pgs. 445-454, Vol. 10, No. 3.	<input type="checkbox"/>

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 Fee set forth in 37 CFR 1.17 (p) has been submitted herewith.  
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A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

Signature	/KEVIN J. DUNLEAVY/	Date (YYYY-MM-DD)	2006-07-26
Name/Print	KEVIN J. DUNLEAVY	Registration Number	32,024

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